



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

June 2, 2026	
IGI Report Number	LG805612884
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	PRINCESS CUT
Measurements	7.03 X 6.96 X 4.91 MM

GRADING RESULTS

Carat Weight	2.01 CARATS
Color Grade	E
Clarity Grade	VS 2

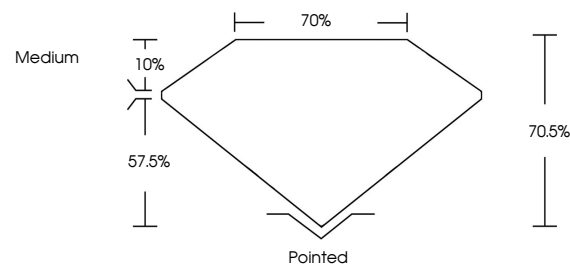
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	13 LG805612884

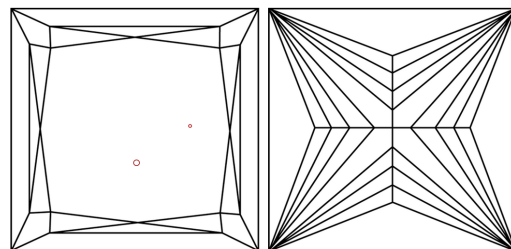
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG805612884
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

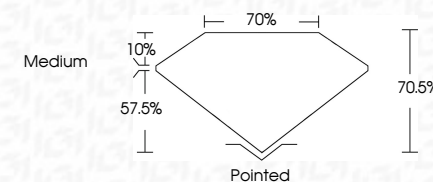
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June 2, 2026
GI Report No LG805612884
PRINCESS CLIT

Carat Weight	201 CARATS
Color Grade	E
Clarity Grade	VS 2
Depth	70.6%
Table	70%
Grade	Medium
Culet	Pointed
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE

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(CVD) growth process.